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1763Invention: **MULTI-CHAMBER SYSTEM HAVING COMPACT INSTALLATION SET-UP FOR AN ETCHING FACILITY FOR SEMICONDUCTOR DEVICE MANUFACTURING****Official****FAX RECEIVED****JUN 30 2000****GROUP 1700**

I hereby certify that this

Preliminary Amendment*(Identify type of correspondence)*is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. **(703) 305-5408**)

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7/3/00**Andrew J. Telesz, Jr.***(Typed or Printed Name of Person Signing Certificate)***Andrew J. Telesz, Jr.***(Signature)***Note: Each paper must have its own certificate of mailing.****A**